

<b>Notice of References Cited</b>	Application/Control No. 10/656,206	Applicant(s)/Patent Under Reexamination FUJII, TAKAYUKI	
	Examiner Sophia S. Chen	Art Unit 2852	Page 1 of 1

**U.S. PATENT DOCUMENTS**

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Name	Classification
	A	US-6,091,927	07-2000	Hattori et al.	399/367
	B	US-			
	C	US-			
	D	US-			
	E	US-			
	F	US-			
	G	US-			
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**FOREIGN PATENT DOCUMENTS**

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**NON-PATENT DOCUMENTS**

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